



UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Makio HIGASHI et al.

Application No.: 10/536,976

Filed: May 31, 2005

For: SUBSTRATE PROCESSING
SYSTEM, COATING/DEVELOPING
APPARATUS AND SUBSTRATE
PROCESSING APPARATUS

Attorney Docket No.: OMY-0044

Examiner: C. R. Ortiz Rodriguez

Art Unit: 2125

Confirmation No.: 6331

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

I. INTRODUCTORY COMMENTS

In response to the Office Action dated August 22, 2007, please amend the above-identified application as set forth below.

Claims 1-6 and 8-12 are pending in the application. By this Amendment, claim 7 is canceled without prejudice or disclaimer and claims 6, 8, 9 and 12 are amended.

Applicants express their appreciation for the Examiner's indication of allowable subject matter in claims 1-5 and 7-12. As a result of the amendments, Applicants believe that the application is now in condition for allowance.

II. AMENDMENTS TO THE SPECIFICATION

(There are no amendments to the specification)

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